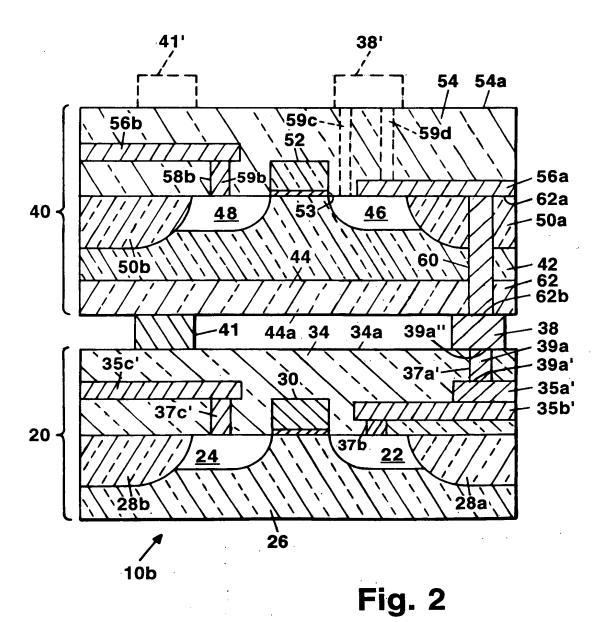
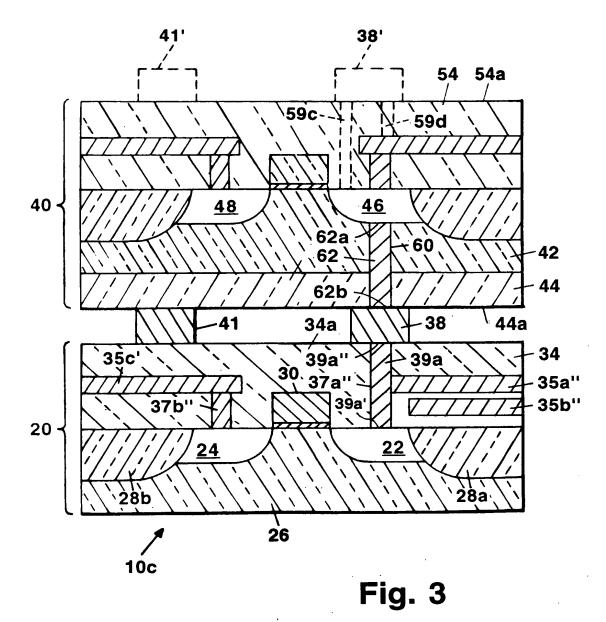


Fig. 1





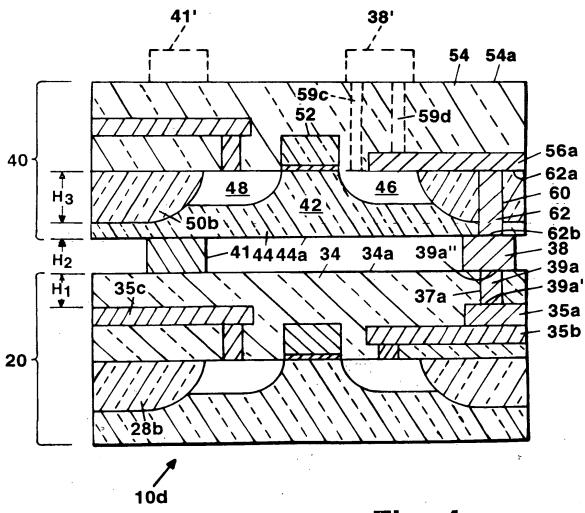


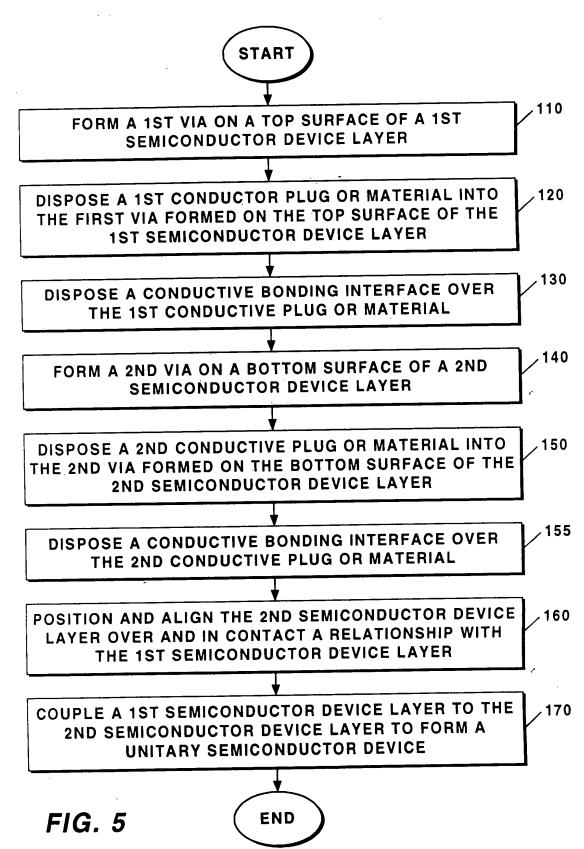
Fig. 4



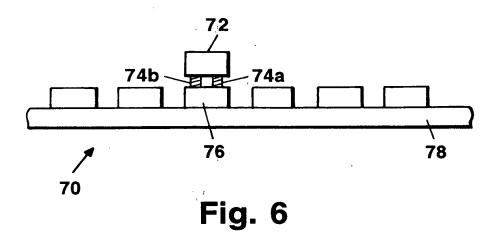
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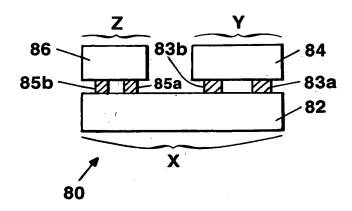


Fig. 7